

**Notice of References Cited**

Application/Control No.

10/670,772

Applicant(s)/Patent Under  
Reexamination  
CHOI, YOUNG-HUN

Examiner

Daniel I. Walsh

Art Unit

2876

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,827,112 A	05-1989	Yoshino et al.	235/380
*	B	US-2003/0055686 A1	03-2003	Satoh et al.	705/3
*	C	US-2003/0134714 A1	07-2003	Oishi et al.	482/6
*	D	US-2003/0212896 A1	11-2003	Kisliakov, Andrew	713/193
*	E	US-2004/0129776 A1	07-2004	Choi, Young-Hun	235/380
*	F	US-2004/0212735 A1	10-2004	Kitamura, Takashi	348/553
*	G	US-6,856,353 B1	02-2005	Misawa, Takeshi	348/333.07
*	H	US-2005/0178833 A1	08-2005	Kisliakov, Andrew	235/441
*	I	US-2005/0231467 A1	10-2005	Gold, Charles D.	345/156
*	J	US-2006/0149977 A1	07-2006	Cooper, Barnes	713/300
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

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